Docket No.: 50395-131

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

TECHNOLOGY CENTER 2800

n re Application of

Kenichi KURISU, et al.

Serial No.: 10/051,023

Filed: January 22, 2002

For: DIFFRACTIVE OPTICAL ELEMENT Group Art Unit: 1746

Examiner: not yet assigned

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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents Washington, DC 20231

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449. It is respectfully requested that the references be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Supplemental Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Each non-English language reference was cited in a corresponding foreign application search report or office action and its relevance discussed therein. A copy of the foreign search report or office action, together with an English language version thereof, is attached for the Examiner's information.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

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Date: September 3, 2002

INFORMATION DISCLOSURE O I S CITATION IN AN APPLICATION (PTO-1449)				ATTY. DOCKET NO. 50395-131		SERIAL NO. 10/051,023		
				APPLICANT Kenichi KURISU, tal.				
				FILING DATE January 22, 2002		GROUP 1746		
		U.S	5. PATEN	T DOCUMEN	NTS			
EXAMINER'S INITIALS	PATENT NO.	DATE		NAME	CLASS	SUBCLASS	FIL	ING DATE
		FORE	IGN PAT	ENT DOCUM	MENTS			
EXAMINER'S INITIALS	PATENT NO.	DATE 12/21/1994		COUNTRY	CLASS	SUBCLASS	nacrona - t-	ranslation
	0 629 592 A		EPO				Yes	No
	0 027 372 11	12/21/177						
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				Process of Ho of America, Vo				
EXAMINER	<u> </u> {			DATE CONSI	IDERED			

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

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